

## Special Issue

# Structured Optical Surfaces and Interfaces, Fabrication and Characterization

### Message from the Guest Editor

It is my pleasure to invite your contributions to this Special Issue, seeking to collect research papers and review articles that focus on the following: (1) fabrication and, (2) characterization of optical structured surfaces and interfaces; including evolutionary, disruptive, revolutionary, and incremental techniques and methods.

- micro- and nano-structured optical surfaces
- bio-mimetic optical structures
- layered metamaterials
- surface hierarchical structures
- optical nano-surface fabrication
- plasmonic and photonic nanopillars
- nanorod arrays
- nanosphere optical layers
- lithographic nano/micro-fabrication
- optical surface modification
- subwavelength diffractive optics
- surface holograms
- nano-imprinting lithography
- optical surface characterization
- metamaterial absorbers
- functional optical surfaces

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### Guest Editor

Prof. Dr. Menelaos K. Poutous

Department of Physics & Optical Science, The University of North Carolina at Charlotte, 9201 University City Boulevard, Charlotte, NC 28223, USA

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### Deadline for manuscript submissions

closed (30 September 2021)



## Micromachines

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*Micromachines*  
Editorial Office  
MDPI, Grosspeteranlage 5  
4052 Basel, Switzerland  
Tel: +41 61 683 77 34  
[micromachines@mdpi.com](mailto:micromachines@mdpi.com)

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## About the Journal

### Message from the Editor-in-Chief

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#### Rapid Publication:

manuscripts are peer-reviewed and a first decision is provided to authors approximately 16.8 days after submission; acceptance to publication is undertaken in 1.9 days (median values for papers published in this journal in the second half of 2025).